SiPM non-linear response





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Why study SiPM non-linearity



Motivation

- SiPMs typically used in linear regime for single photon detection
- Pixel-like design leads to non-linear response to high photon numbers
- \longrightarrow Limits potential usage

Problems

- Time/spatial distribution of incoming photons
- Noise effects: cross-talk, delayed cross-talk and after-pulsing
- Partial pixel recovery
- Type of measurement: amplitude vs. charge
- No satisfying publications yet

Scope of Thesis



- Develop reliable method to asses non-linear response in SiPM
- Done by analysing statistical moments from integrated charge spectra
- Comparison with simulation
- Apply Generalised Poisson treatment to evaluate non-linearity
- SiPM response characterization based on the first three statistical moments (mean, variance, and skewness) as laid out in [S. Vinogradov (2022)]
- \longrightarrow More possible application

SiPM non-linear response

- Charge generated by pixel avalanche q_{pixel}
- SiPM signal is charge generated by all fired pixels N_{fired}

 $Q = q_{\text{pixel}} \cdot N_{\text{fired}}$

SiPM response is linear as long as all photons hit different pixels \longrightarrow





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Exemplary studies on SiPM response



Number of fired pixels as a function of incident photons: $N_{\text{fired}} = N_{\text{pix}} \cdot \left(1 - \exp\left(-\frac{\epsilon_{\text{PDE}}N_{\gamma}}{N_{\text{pix}}}\right)\right)$

Photon detection efficiency: ϵ_{PDE}



Measurement Setup



• Method: Determine non-linearity by measuring the change in amplitude of fixed, small light pulse added onto variable intensity base pulse





- $d\varphi$: LED, I : LASER, dI : LED*
- $\bullet\,$ Add fixed, small amplitude $\mathrm{d}\varphi$ to existing amplitude / to give / $+\,\mathrm{d}$ /
- Measure non-linearity with $(I + dI) I \leq d\varphi$

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Measurement Procedure



- Set LASER intensity with neutral density filters
- Integrate pedestal and pulse region with scope
- Turn on the LED light
- Integrate pedestal and pulse region with scope

Go to step 1 and repeat





Pedestal low light

Pulse low light

Pedestal high light





Pulse high light

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2000

1500

500

270

Data analysis



Mean and variance are corrected by subtracting corresponding pedestal value

 $dI = \mu_{LASER+LED} - \mu_{LASER}$

Assess non-linearity by comparing $\mathrm{d} I$ with the mean of LED $\mathrm{d} \varphi$

 $rac{\mathrm{d} \textit{I}}{\mathrm{d} arphi} = 1, \quad \text{only for linear response}$

Future

Future Generalised Poisson treatment Charge moments μ_i

$$\mu_i(Q_{photo}) = \mu_i(Q_{on}) - \mu_i(Q_{off}), \quad i = 1, 2, 3$$

$$\mu_1(Q_{photo}) = \mu = \eta \frac{1}{(1-\lambda)}g$$

$$\mu_2(Q_{photo}) = \sigma^2 = \eta \frac{1}{(1-\lambda)^3}g^2$$

$$\mu_3(Q_{photo}) = \gamma \cdot \sigma^3 = \eta \frac{1+2\lambda}{(1-\lambda)^5}g^3$$

mean: η , cross-talk events: λ ,
kewness: γ , gain: g

Pure Poisson $\mu_1 = \mu_2 = \mu_3 = \eta$, deviation towards GP as sign of non-linearity [S. Vinogradov (2022)]

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Measurement settings

- SiPM: Hamamatsu MPPC S14160-1315PS
 - Pixel pitch 15 µm
 - Sensitive area 1.3×1.3 mm
 - Number of pixels 7296
 - $\bullet \ V_{over} = 3.8 \, V$
- LASER: ASL EI61000D
 - $\lambda = 451\,\mathrm{nm}$
 - $\bullet \ t=50\,ps$
- LED: PicoQuant PLS 450
 - $\lambda = 458\,\mathrm{nm}$
 - $t = 890 \, \text{ps}$
- Integration window 20 ns
 - due to reflection at various fiber connections
- Bandwidth 20 MHz
 - ${\ensuremath{\, \bullet }}$ resolve pulse heights from mV to V in one scale

SiPM non-linear response





LASER



LED

Bifurcated Fiber



Box with SiPM

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Proof of concept: Mean and measure of non-linearity





- $\bullet\,$ Saturation already visible for $t_{gate}=20\,\text{ns}$
- Exact saturation level requires more precise characterisation
- Add more data points

Outlook



- Iron out kinks in setup
 - Reflections
 - Optimal Oscilloscope settings
 - Minor technical issues
- Start take first data sets
- Implement the GP treatment of non-linearity

Thank You





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Data analysis - Moments of statistics



- Each measurement steps results in 4 charge spectra
 - LASER, pedestal for LASER, LASER+LED, pedestal for LASER+LED
- Compute the mean, variance, and skewness of the histograms



 f_i : counts, x_i : bins [Stephen Kokoska and Daniel Zwillinger (1999)]

Mean, Variance and Skewness
$\mu = \frac{m_1'}{N}$ $\sigma^2 = \sqrt{\frac{m_2}{N-1}}$ $\gamma = \frac{N\sqrt{N-1}}{N} \frac{m_3}{3/2}$
$m - 2 m_2^{-1}$

Backup – variance and skewness





